Docket No. 2001-1368 Appln. No. 10/520,117

AMENDMENTS TO THE SPECIFICATION:

Please insert the following heading on page 1, before line 1, as follows:

TITLE OF THE INVENTION

Please insert the following heading on page 1, between lines 2 and 3, as follows:

BACKGROUND OF THE INVENTION

Please insert the following heading on page 1, between lines 5 and 6, as follows:

DESCRIPTION OF THE RELATED ART

Please insert the following heading on page 2, between lines 8 and 9, as follows:

SUMMARY OF THE INVENTION

Please insert the following heading on page 4, between lines 5 and 6, as follows:

BRIEF DESCRIPTION OF THE DRAWINGS

Please insert the following heading on page 4, between lines 11 and 12, as follows:

DESCRIPTION OF THE PREFERRED EMOBIMENTS

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Please replace the paragraph beginning at page 4, line 27, with the following rewritten paragraph:

A porous electron-conducting layer $\underline{7}$, such as a layer of nickel oxide which on sintering and reduction is converted to porous nickel is applied to layer 6. The thickness of such a layer is less than 100 μ m, preferably approximately 50 μ m, at the time of application, so that a layer thickness of 10 - 20 μ m results on sintering.

Please replace the paragraph beginning at page 5, line 5, with the following rewritten paragraph:

A current collector $\underline{8}$, indicated highly diagrammatically, presses against layer 7.